

## EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	62	matsuzawa-akira.in.	US-PGPUB; USPAT	OR	OFF	2006/06/10 08:14
L2	6	1 and ((etch\$3 same selectiv\$3) same passage)	US-PGPUB; USPAT	OR	OFF	2006/06/10 08:20
L3	4	shimada-masato.in. and ((etch\$3 same selectiv\$3) same passage)	US-PGPUB; USPAT	OR	OFF	2006/06/10 08:20
L4	4795	(etch\$3 same selectiv\$3) same (polysilicon same dop\$4)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/06/10 08:22
L5	7	L4 same (ink near jet print\$3 near head)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/06/10 08:21
L6	1108	((etch\$3 same selectiv\$3 or impart\$3) and (passage and space or open\$3) and (print\$3 or eject\$3)).clm.	US-PGPUB; USPAT	OR	OFF	2006/06/10 08:28
L7	709	6 and @pd<"20000117"	US-PGPUB; USPAT	OR	OFF	2006/06/10 08:24
L8	9	7 and (ink near chamber)	US-PGPUB; USPAT	OR	OFF	2006/06/10 08:26
L9	4	7 and (vibrat\$3 near plate)	US-PGPUB; USPAT	OR	OFF	2006/06/10 08:27
L10	0	((etch\$3 same selectiv\$3 or impart\$3) and (passage and space or open\$3) and (print\$3 or eject\$3)).clm.	EPO; JPO; DERWENT	OR	OFF	2006/06/10 08:28
L11	246	(etch\$3 same selectiv\$3 or impart\$3) same ((passage and space or open\$3) and (print\$3 or eject\$3))	EPO; JPO; DERWENT	OR	OFF	2006/06/10 08:34
L12	11	(etch\$3 same selectiv\$3 or impart\$3) same ((boron near dop\$3) same polysilicon)	EPO; JPO; DERWENT	OR	OFF	2006/06/10 08:35